

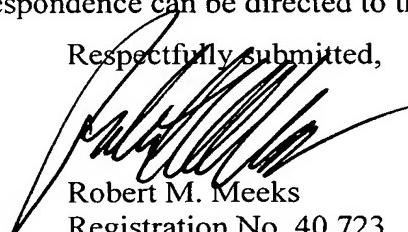
REMARKS

This Response to Restriction Requirement is responsive to the Office Action mailed June 9, 2005 (hereinafter "Office Action"). Restriction is requested between one of two groups. As alleged in the Office Action, Group I (Claims 1-15) is "drawn to a method of forming a multi-layer dielectric structure," while Group II (Claims 16-20) is "drawn to an apparatus for forming multi-layer dielectric structures." Office Action, p. 2. Applicants elect Group I, Claims 1-15 without traverse. Claims 16-20 have been canceled without prejudice towards pursuing these claims in a divisional application.

Also filed concurrently herewith are a Second Supplemental Information Disclosure Statement and Form PTO-1449 submitting references cited in a Notice to Submit Response in the corresponding Korean application. Applicants respectfully request consideration and acknowledgement of these references by the Examiner initialing the Form PTO-1449 and returning a copy to Applicants.

Applicants respectfully submit that this application is in condition for substantive examination of Claims 1-15, which is respectfully requested. Any questions that the Examiner may have regarding this correspondence can be directed to the undersigned.

Respectfully submitted,



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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 6, 2005.



Candi L. Riggs